

OK TO ENTER: /K.M.V./

OMM Docket No. 844,004-303
(VIP Docket No. STI-005)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Brian H. Moeckly et al.

Serial No.: 10/726,232

Filed: December 1, 2003

For: GROWTH OF IN-SITU THIN FILMS
BY REACTIVE EVAPORATION

Group Art Unit: 1793

Confirmation No.: 3720

Examiner: VIJAYAKUMAR,
KALLAMBELLA M.

OK TO ENTER: /K.M.V./

June 05, 2008.

AMENDMENT AFTER FINAL

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed on May 1, 2008, please consider the following amendments and remarks:

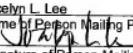
Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

CERTIFICATE OF TRANSMITTAL

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being transmitted to the Commissioner for Patents, P.O. BOX 1450, Alexandria, VA 22313-1450 on the date shown below via the USPTO EFS-Web filing system.

May 21, 2008
Date of Deposit

Jocelyn L. Lee
Name of Person Mailing Paper

Signature of Person Mailing Paper